

FORM PTO-1449 (SUBSTITUTE) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  INFORMATION DISCLOSURE STATEMENT BY APPLICANT (37 CFR 1.98(b))	Attorney Docket No.: P2002,0889  Applicant Martin Rößiger et al.  Filing Date October 16, 2003	Applic. No. 10/686,848  Group Art Unit
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## U.S. PATENT DOCUMENTS

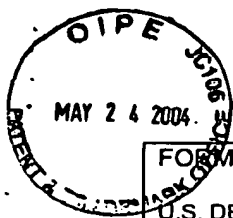
EXAMINER INITIALS		PATENT NO.	DATE	PATENTEE	CLASS	SUB CLASS	FILING DATE
	A						
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## FOREIGN PATENT DOCUMENT

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB CLASS	TRANSL. YES   NO
	J						
	K						
	L						
	M						
	N						

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

	O	Jens Staecker et al.: "Advances in Process Overlay on 300 mm wafers", SPIE Conference, March 3-8, 2002;
	P	Paul C. Hinnen et al.: Advances in Process Overlay", SPIE Conference, March 3-8, 2002
EXAMINER		DATE CONSIDERED 9/20/04
EXAMINER: Initial citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.		



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U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE

Applicant

Martin Rößiger et al.

INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT  
(37 CFR 1.98(b))

Filing Date

October 16, 2003

Group Art Unit

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2814

## U.S. PATENT DOCUMENTS

EXAMINER INITIALS		PATENT NO.	DATE	PATENTEE	CLASS	SUB CLASS	FILING DATE
<i>WJ</i>	A	5,451,479	09/19/95	Ishibashi			
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	I						

## FOREIGN PATENT DOCUMENT

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB CLASS	TRANSL. YES   NO
<i>not considered no translation WJ</i>	J	44 14 369 C2	10/27/94	Germany			
	K						
	L						
	M						
	N						

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

	O	
	P	

EXAMINER

*Vicki Smith*

DATE CONSIDERED

*9/20/04*

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.